

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Granneman
Appl. No.	:	Unknown
Filed	:	Herewith
For	:	APPARATUS AND METHOD FOR ATOMIC LAYER DEPOSITION ON SUBSTRATES
Examiner	:	Unknown

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Prior to examination on the merits, please amend the subject application as indicated below.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.